



05-25-06

Docket No. 8092/SYNX/SYNX/JW *ITK*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Inventor(s): Michael R. Rice, Martin R. Elliott, Robert B. Lowrance, Jeffrey C. Hudgens and Eric A. Enghardt
Title: OVERHEAD TRANSFER FLANGE AND SUPPORT FOR SUSPENDING A SUBSTRATE CARRIER
Serial No.: 10/764,820
Filed: January 26, 2004
Examiner: Greenhut, Charles N.
Group Art Unit: 3652

Transmitted herewith is:

- ☒ PTO Form 1449;
- ☒ Information Disclosure Statement with six cited references; and
- ☒ Return Postcard.

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	N/A	- 20 =	-0-	X \$50.00	\$0.00
Independent Claims	N/A	- 3 =	-0-	X \$200.00	\$0.00
Basic Filing Fee (\$300.00), Utility Search Fee (\$500.00), Utility Examination Fee (\$200.00)				\$1000.00	\$0.00
TOTAL FEES					PAID

- ☒ The Commissioner is hereby authorized to charge \$180.00 to Deposit Account No. 04-1696.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 04-1696. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:
Customer # 41161
Dugan & Dugan, PC
55 South Broadway
Tarrytown, NY 10591

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Express Mail Receipt No. EV605114859US
Date of Deposit: 5/23/06
Signature: *[Signature]*

Respectfully submitted,
[Signature]
Brian M. Dugan
Registration No. 41,720
(914) 332-9081



Express Mail Label No. EV605114859US

PATENTS
8092/SYNX/SYNX/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Michael R. Rice et al.
Serial No. : 10/764,820
Filed : January 26, 2004
For : OVERHEAD TRANSFER FLANGE AND SUPPORT FOR
SUSPENDING A SUBSTRATE CARRIER
Group Art Unit : 3652
Customer No. : 41161
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97,
applicants wish to call the attention of the Examiner to the
following references:

Foreign Art Reference No. EP 0663686 B1 (EPO)

Foreign Art Reference No. EP 0795892 A1 (EPO)

Weiss, Mitchell, "Evaluating 300-mm Fab Automation
Technology Options and Selection Criteria", June 1997, MICRO,
Vol. 15, No. 6, pages 65-66, 68, 70, 72, 74, 76, 78-79.

No-Author, "Equipe Helps Streamline 300 mm Wafer Processing", Dec. 1, 1997, Manufacturing Automation, Vol. 7, No. 3, page 1-5.

No-Author, "PRI Selected By Varian Semiconductor to Supply 300mm Integrated Front-End Buffering Solutions", Feb. 10, 2000, Newswire, Page 7434.

No-Author, "300mm Single-Wafer Handling" (Brief Article), Apr. 1, 2000, Solid State Technology, Vol. 43, No. 4, page 99.

Please charge deposit account No. 04-1696 in the amount of \$180.00 for consideration of this information disclosure statement under 37 C.F.R. § 1.97(c)(2).

These references are also listed on the accompanying Information Disclosure Statement (Form PTO-1449).

Consideration of the foregoing in relation to this patent application is respectfully requested.

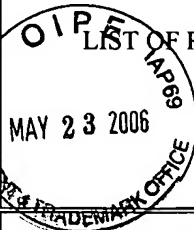
Respectfully Submitted,



Brian M. Dugan, Esq.
Registration No. 41,720
Dugan & Dugan, PC
Attorneys for Applicants
(914) 332-9081

Dated: 5/23/06
Tarrytown, New York

U.S. Department of Commerce, Patent and Trademark Office

Docket No.:
8092/SYNX/SYNX/JWSerial No.:
10/764,820

LIST OF RELEVANT ART CITED BY APPLICANT

(Use several sheets if necessary)

Applicants:

Michael R. Rice et al.

Filing Date:

January 26, 2004

Group:

3652

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
	US-1						
	US-2						
	US-3						
	US-4						
	US-5						
	US-6						
	US-7						
	US-8						
	US-9						
	US-10						
	US-11						

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	F-1	EP 0663686 B1	06/18/97	EPO			X	
	F-2	EP 0795892 A1	09/17/97	EPO			X	
	F-3							
	F-4							
	F-5							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	OT-1	Weiss, Mitchell, "Evaluating 300-mm Fab Automation Technology Options and Selection Criteria", June 1997, MICRO, Vol. 15, No. 6, pages 65-66, 68, 70, 72, 74, 76, 78-79.
	OT-2	No-Author, "Equipe Helps Streamline 300 mm Wafer Processing", Dec. 1, 1997, Manufacturing Automation, Vol. 7, No. 3, page 1-5.
	OT-3	No-Author, "PRI Selected By Varian Semiconductor to Supply 300mm Integrated Front-End Buffering Solutions", Feb. 10, 2000, Newswire, Page 7434.

Examiner

Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

U.S. Department of Commerce, Patent and Trademark Office LIST OF RELEVANT ART CITED BY APPLICANT (Use several sheets if necessary)	Docket No.: 8092/SYNX/SYNX/JW	Serial No.: 10/764,820
	Applicants: Michael R. Rice et al.	
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U.S. Patent Documents							
*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
	US-12						
	US-13						
	US-14						
	US-15						
	US-16						
	US-17						
	US-18						
	US-19						
	US-20						
	US-21						
	US-22						

Foreign Patent Documents							Translation	
		Document Number	Date	Country	Class	Subclass	Yes	No
	F-6							
	F-7							
	F-8							
	F-9							
	F-10							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)		
	OT-4	No-Author, "300mm Single-Wafer Handling" (Brief Article), Apr. 1, 2000, Solid State Technology, Vol. 43, No. 4, page 99.
	OT-5	
	OT-6	

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